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#### PATENT APPLICATION

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
••	: Examiner: M. A. Lyons
Ryo TAKAI et al.	)
Application No.: 10/073,593	: Group Art Unit: 2877
Application 10. 10/0/3,333 C	: Confirmation No. 4328
Filed: February 12, 2002	)
	: Allowed: February 27, 2004
For: EXPOSURE APPARATUS INCLUDING	)
INTERFEROMETER SYSTEM	· March 18, 2004

#### Mail Stop ISSUE FEE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## LETTER REQUESTING CONSIDERATION OF PAPERS TIMELY FILED

Sir:

Applicants have received a Notice of Allowance and a Notice of Allowability dated Friday, February 27, 2004, in the above-identified application. Applicants filed a Supplemental Information Disclosure Statement (with a statement) on Monday, March 1, 2004, prior to receipt of the Notice of Allowance on March 2, 2004. Accordingly, Applicants request that the Examiner indicate consideration of the material submitted in that Information Disclosure Statement by initialing and returning a copy of the PTO-1449 form attached to that paper. Attached, for the Examiner's convenience, are copies of the Supplemental Information Disclosure Statement, the PTO-1449 form, and the U.S. Patent and Trademark Office date stamped postcard receipt indicating the filing of those papers on that date.

Applicants believe that no fees should be incurred in connection with filing this paper. However, the Commissioner is authorized to charge Deposit Account No. 06-1205, should any fees be associated herewith. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

Attorney for Applicants

Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

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	Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	Date 3 / 2004  Mo. Day Yr.  Atty. Doctor 020516
FCHS-D-00	Sir:  Kindly acknowledge receipt of the accompanying:  Response to Official Action.  Check for \$	priority applications
		).



00862.022516.

#### PATENT APPLICATION

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)		
Ryo TAKAI et al.	: Examiner: M. A. Lyons		
•	: Group Art Unit: 2877		
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Commissioner for Patents P.O. Box 14590 Alexandria, VA 22313-1450

#### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed April 30, 2002, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

The information enclosed with this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing date of this Statement. Specifically, the attached Korean Office Action dated January 14, 2004, was cited in a counterpart Korean patent application. A translation of this Office Action will be provided if the Examiner so requires.

Korean patent document number 2000-0070669 corresponds to PCT publication number WO 99/28790, copy also enclosed. A translation of the Korean patent document will be provided if the Examiner so requires.

Japanese patent document number 2000-049066 corresponds to U.S. Patent No. 6,285,457, copy also enclosed. The Examiner will note that this patent was cited in the

Office Action dated July 16, 2003.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Steven É. Warner

Registration No. 33,326

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New York, New York 10112-3801

Facsimile: (212) 218-2200

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		MAR 1 8 2004				
FORM PTO 1449 (n	nodified)	AT AT	DOCKET NO. 00862.022516.	APPLICATI	on no. 10/07	<b>'</b> 3,593
U. PA	S. DEPARTMENT OF COMMERC ATENT AND TRADEMARK OFFIC	E .	PPLICANT Ryo TAKAI et al.		· · ·	
LIST OF	REFERENCES CITED BY APPLIC (Use several sheets if necessary)	CANT(S) ADEMA				
	March 1, 2004	FIL	ING DATE February 12, 2002	G	ROUP 2877	
		U.S.	PATENT DOCUMENTS			
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	US-6,285,457 B2	09/04/2001	Ukaji	356	500	
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<b>,</b>		FOREIG	GN PATENT DOCUMENTS	<del></del>	· · · · · · · · · · · · · · · · · · ·	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	2000-0070669	11/25/2000	Korea			No
	WO 99/28790	06/10/1999	PCT			
	2000-049066	02/18/2000	Japan			Abstract
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		THER DOCUMENT(S) (In	cluding Author, Title, Date, Pertinent Pages, Etc.	)		
Korean Office Action dated January 14, 2004, issued in a corresponding Korean patent application, No. 10-2002-0008059.						
ÉXAMINER	1		DATE CONSIDERED			

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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.